RECEIVED **CENTRAL FAX CENTER**

MAY 0 9 2005

400 Garden City Plaza Garden City, New York 11530 (516) 742-4343 - Telephone (516) 742-4366 - Facsimile e:mail: intrprop@ssmp.com

2. Response under 37 CFR 1.111 3. Certificate of Facsimile

SCULLY, SCOTT, MURPHY & PRESSER



To:	Examiner J.A. Garcia Group Art Unit: 2823			From:	Leslie S. Szivos, Ph.D.				
Fax:	703-	872-9306		Pages:	11 including cover				
Phone	13			Date:	5/9/2005				
Re:	U.S.	Cabral, Jr., et al. Patent Appln. No. Docket: YOR92003	•	CC:					
XX Un	gent	☐ For Review	□ Please Com	ıment	☐ Please Reply	☐ Please Recycle			
Dear S	ir:								
The fo	llowing	g is attached hereto	:						
1.	Amen	dment Transmittal i	n duplicate						

CONFIDENTIALITY: The documents accompanying this facsimile transmission may contain information which is either confidential or legally privileged and is intended only for the authorized use of the Individual or entity named above without right or publication or republication, dissemination or disclosure except as expressly set forth or established by course of dealing. All rights are reserved. If you are not the intended recipient, you are hereby notified that any disclosure, copying, distribution or use of the contents of this facsimile is prohibited. If you received this transmission in error, please notify us immediately by telephone to arrange for return of the documents.

If you have any problems concerning this facsimile, please call (516) 742-4343 and ask for Janelle ward @ext 587.

CERTIFICATE OF TI Applicant(s): Cyril Cabral	Docket No. YOR920030194US1 (16695)				
Application No. 10/643,534	Filing Date 8/19/2003	Examiner J.A. Garcia	Group Art Unit 2823		
Invention: ATOMIC LAY	ER DEPOSITION OF META	LLIC CONTACTS, GATES A	ND DIFFUSION BARRIERS		
I hereby certify that this	RE	SPONSE UNDER 37 CFR 1.11	11		
is being facsimile transmitt	ed to the United States Patent	(Identify type of correspondence) t and Trademark Office (Fax.)	No. 703-872-9306		
_		i and Tradomain omos (Fam.)	700 072 7000		
On May 9, 200 (Date)	<u></u>				
(Duie)		•			
)		
			egistration No. 39,394		
,		(Typed or Printed Name of Pers	son signing Certificate)		
		(Signatur	<u> </u>		
	•	/ (Digitality)	•		
,					
	Note: Each paper must be	ive its own certificate of mailing.			
		g.			

AMENDMENT TRANSMITTAL LETTER (Lawre Entity)							
AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Cyril Cabral Jr., et al.					Docket No. YOR920030194US1 (16695)		
Application No. 10/643,534	Filing Date Examiner Customer N 8/19/2003 J.A. Garcia 23389		No.	Group Art Unit 2823	Confirmation No. 4259		
Invention: ATOMIC LAYER DEPOSITION OF METALLIC CONTACTS, GATES AND DIFFUSION BARRIERS							
		COMMISSIONER FO	R PATENTS:				
		n the above-identified a mitted as shown below.	•				
		CLAIMS AS AM	ENDED				
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE		ADDITIONAL FEE	
TOTAL CLAIMS	26 -	30 =	0	x	\$50.00	\$0.00	
INDEP. CLAIMS	3 -	3 =	0	x	\$200.00	\$0.00	
Multiple Depender	t Claims (check if appl	icable)				\$0.00	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$0							
No additional fee is required for amendment. □ Please charge Deposit Account No. in the amount of □ A check in the amount of to cover the filing fee is enclosed. □ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM □ Any additional filing fees required under 37 C.F.R. 1.16. □ Any patent application processing fees under 37 CFR 1.17. □ Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. Dated: May 9, 2005 Leslie S. Szivos, Ph.D.							
Registration No. 39, 394 Inhereby certify that this correspondence is being deposited the United States Postal Service with sufficient postage as class mail in an envelope addressed to "Commissioner for Pat P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] of (Date) Signature of Person Mailing Correspondence Typed or Printed Name of Person Mailing Correspondence Typed Or P							

AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Cyril Cabral Jr., et al.					il -	Docket No. YOR920030194US1 (16695)			
Application No. 10/643,534	Filing Date 8/19/2003	Examiner J.A. Garcia		ustomer N 23389	No. Group Art Ur 2823		Confirmation No. 4259		
Invention: ATO	Invention: ATOMIC LAYER DEPOSITION OF METALLIC CONTACTS, GATES AND DIFFUSION BARRIERS								
COMMISSIONER FOR PATENTS: Transmitted herewith is an amendment in the above-identified application.									
The fee has been	calculated and is trans	mitted as shown below	'• 			* ***			
		CLAIMS AS AM	ENDED						
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST# PREV. PAID FOR		BER EXTRA		RATE	ADDITIONAL FEE		
TOTAL CLAIMS	26 -	30 =	(\$50.00	\$0.00		
INDEP. CLAIMS			x	\$200.00	\$0.00				
Multiple Dependen	t Claims (check if app	licable)	•				\$0.00		
		TOTAL ADDITIONAL	FEE FOR	THIS AME	END	MENT	\$0.00		
No additional fee is required for amendment. Please charge Deposit Account No. in the amount of A check in the amount of to cover the filing fee is enclosed. The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM Any additional filing fees required under 37 C.F.R. 1.16. Any patent application processing fees under 37 CFR 1.17. Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form Provide credit card information and authorization on PTO-2038. Dated: May 9, 2005 Leslie S. Szivos, Ph.D.									
Registration No. 39, 394 hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on Signature of Person Mailing Correspondence									

MAY 0 9 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Cyril Cabral Jr., et al.

Examiner:

J.A. Garcia

Serial No:

10/643,534

Art Unit:

2823

Filed:

August 19, 2003

Docket:

YOR920030194US1 (16695)

Dated:

May 9, 2005

For:

ATOMIC LAYER DEPOSITION OF METALLIC CONTACTS,

GATES AND DIFFUSION BARRIERS

Confirmation No.: 4259

Mail Stop Amendment Commissioner for Patents United States Patent Office Alexandria, VA 23313-1450

RESPONSE UNDER 37 C.F.R. § 1.111

Sir:

In response to the Office Action dated February 9, 2005, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: May 9, 2005

Leslie S. Szivos, Ph.D.